



ECLIPSE MA200 MA100N

Inverted Metallurgical Microscopes



ECLIPSE MA200/MA100N

Nikoa Colacian Maleron

Model features

MA200

Offers high stability, durability, and a smaller footprint than conventional models, as well as easy access to the stage handle, the nosepiece, the BF/DF change lever, and diaphragms, all located at front side.

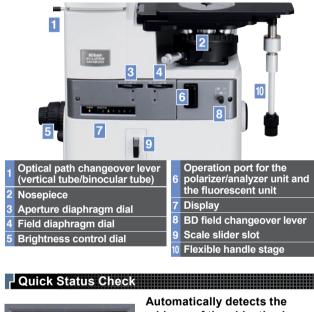
		Brightfield	Darkfield	Simple polarizing	DIC	Fluorescence
Compatible observation		\bigcirc	0	\bigcirc	\bigcirc	\triangle
methods		*DIA illuminator i \triangle : only availab		ansmitted light ob _amp and Fiber II		
Compatible illminators	 LV-LH50PC 12V50W Halogen Lamp Illuminator C-HGFI HG Precentered Fiber Illuminator (*option) LV-LL LED Lamphouse 					
Magnification module		● 1x/1.5x/2x				
Compatible stages		 MA2-SR Mechanical Stage (stroke: 50 x 50 mm) 				



ECLIPSE MA200

Front Operation

Delivers ease-of-use by placing all important controls at the front of MA200N.





Automatically detects the address of the objective lens currently in use and displays it on the main unit front panel.

The observation position of the objective lens and sample can be checked easily from the microscope's front panel.

Box Structure

The unique box structure is 1/3 smaller than conventional models and offers improved durability.

Compact structure with a depth of 315 mm

A box shaped microscope, not only the width but also the depth is reduced dramatically: The foot print is only one-third of the conventional model!

High stability and durability

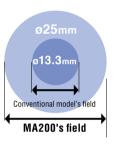
Reduced vibration during high-power observation, offering a highly rigid microscope.

Evolved Optical Performance

Provides a more ergonomic observation with clearer images.

Super-wide field of view

A sample with a diameter of just 25 mm can be observed in an one field of view by combining the ultra wide field of view eyepiece and 1x objective lens.





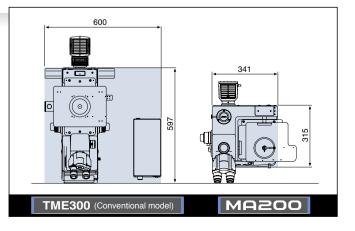
Even Illumination

Improved uniformity of illumination delivers clear images, especially for digital imaging.

Combine images with the stitching feature

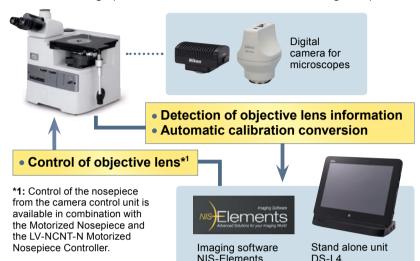
Can combine up to eight images with uniform lighting and no seams.





Combination with **Digital Camera**

The MA200 allows detection of information and control of objective lenses, enabling optimization of the conditions vital for image acquisition.



Accessories

Stage

Samples can be rotated by the stage clip. The stage delivers high durability needed to support heavy samples.

1 MA-2 SR Stage



NIS-Elements

DIC Units

Standard and high contrast type DIC prism are available to match needs of the sample.

These prisms are effective for observation of minute step heights.

1 MA2-PA Unit 2 L-DIHC DIC Prism (High Contrast) 3 L-DIC DIC Prism

Nosepiece & Magnification Module

Enables communication of objective lens position, magnification and intermediate magnification module information with the DS-L4 control unit and NIS-Elements image software.

1 MA2-MC Magnification Module 2 LV-NU5I Intelligent Universal Quintuple Nosepiece



Illumination

Expanded lineup

Added a compact LED illuminator to the existing lineup. With the use of LED, Nikon illuminators are power saving and achieve long life.



LV-LL LED Lamphouse

Holders

A full lineup is available that correspond to a variety of sample shapes.



Polarizing Units

Polarizing observation is effective for birefringence samples. MA2-PA unit is suitable for observation of aluminium.

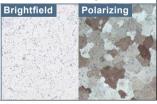
Single-action operation

Links the attachment/release of the analyzer/polarizer.

- 1 MA2-PA Unit 2 MA2-UPA Unit*
- 3 MA2- $\lambda P \lambda$ Plate *It is suitable for inspecting aluminium sample



Aluminium sample



Grain Size Reticle & Scale

Overlays a pattern onto the observed image. The Grain Size Reticle is used for grain size analysis and complies with the JIS G0551 and ASTM E112 standards. The Scale displays a scale for each objective lens magnification.

MA2-GR Grain Size Reticle JIS G0551/objective lense 10x (100× magnification) ASTM E112/objective lense 10x (100× magnification) 2 MA2-MR Scale



MA100N

A durable, user-friendly Inverted Microscope with superior image quality, a small footprint and great cost performance.

Illumination

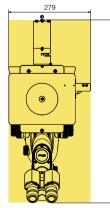
Employment of high-intensity LED illumination (Eco-illumination)

Compared to conventional halogen illumination, these high intensity LED sources need only about one third of consuming electricity and last approximately 30 times longer. The MA100N ensures stable sample observation with uniform color temperature even in different light intensity.

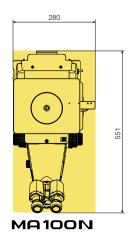


Compact Body Redesigned to be smaller

Designed for LED illumination, the footprint is 11% smaller than conventional models, allowing users to have more installation choices.



Previous model (MA100L)



Stage

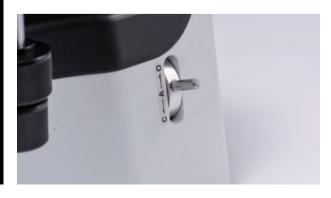
Controlled stability even with heavy samples/ Boasts superior durability

The MA-SR-N Rectangular Stage was developed especially for the MA100N. The three-plate structure allows for observation of heavy samples, such as a grinder resin mounted samples.



Aperture Diaphragm Standard with MA100N

The epi illuminator comes standard with a variable aperture diaphragm to control image contrast and depth of field.





Accessories



Digital Camera

Redesigned with optical systems suitable for sample observations. The camera port is located on the side of MA100N to provide improved visibility of the stage.

Microscope Camera DS-Fi3 C-0.63x-TS2 C-mount Adapter

3 TS2-P-CF Camera port 100



Basic stage set

A triple-platform stage structure lets you use heavy samples.

- MA-SR-N Rectangular Stage N Specimen Holder
- (ø20/30/40mm aperture) MA-SH3 Specimen Holder 3
- 4 MA-SRSH1 Universal Specimen Holder



Grain size reticle

The class of grain size in a sample can be easily distinguished while observing its image.



MA100-EPRGS Grain Size Reticle

Other accessories

TI-SM Mechanical Stage CH
 MA-SP-N Plain Stage N
 MA-SH2-N Specimen Holder 2N
 MA-S-HU Universal Holder
 MA-SH3 Specimen Holder 3
 MA-SRSH 25-40 Holder

- MA-SRSH1 Universal Specimen Holder
 MA-SH1-N Specimen Holder 1N
 MA-P/A Simple
 - Polarizer



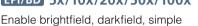
Accessories

CF160-2

Nikon's CFI60 optical system, highly evaluated for its unique concept of high NA and long working distance, has achieved the apex in long working distance, chromatic aberration correction, and light weight.

Standard objective lenses

TU Plan Fluor Series



Enable brightfield, darkfield, simple polarizing, sensitive polarizing, differential

interference, and epi-fluorescence observations with just one lens. Achieves superior chromatic aberration performance with long working distance for all magnifications to adapt to any application.



*Brightfield observation (EPI) objective lens

Long

WD

Light

weight

apo

Fly-eye

lens

Model	Magnification	NA	Working Distance (mm)
Woder	waynincation		Working Distance (iiiii)
TU Plan Fluor EPI	5×	0.15	23.5
(brightfield type)	10×	0.30	17.5
	20×	0.45	4.5
	50×	0.80	1.0
	100×	0.90	1.0
TU Plan Fluor BD	5×	0.15	18.0
(brightfield/darkfield type)	10×	0.30	15.0
	20×	0.45	4.5
	50×	0.80	1.0
	100×	0.90	1.0

Long working distance objective lenses TU Plan ELWD Series

EPI/BD 20x/50x/100x 🛛 🧼



With the phase Fresnel lenses, these objective lenses enable long working distances while

offering higher level chromatic aberration correction than conventional objective lenses. This improves operability for samples with different heights.



Brightfield observation (EPI) objective le	en
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Model	Magnification	NA	Working Distance (mm)
TU Plan EPI ELWD	20×	0.4	19.0
(brightfield type)	50×	0.6	11.0
	100×	0.8	4.5
TU Plan BD ELWD	20×	0.4	19.0
(brightfield/darkfield type)	50×	0.6	11.0
	100×	0.8	4.5

Low-magnification objective lenses

T Plan EPI EPI 1x/2.5x Both clear observation using a

conventional analyzer/polarizer and operability-oriented observation without the need of an analyzer/ polarizer are possible.



Model	Magnification	NA	Working Distance (mm)
T Plan EPI	1×	0.03	3.8
(brightfield type)	2.5×	0.075	6.5

Apochromatic objective lenses TU Plan Apo Series



EPI/BD 50x/100x/150x

lenses, these objective lenses achieve significantly longer operating distances while maintaining the superior chromatic aberration performance of apochromatic lenses.



*Brightfield observation (EPI) objective lens

Model	Magnification	NA	Working Distance (mm)
TU Plan Apo EPI	50×	0.8	2.0
(brightfield type)	100×	0.9	2.0
	150×	0.9	1.5
TU Plan Apo BD	50×	0.8	2.0
(brightfield/darkfield type)	100×	0.9	2.0
	150×	0.9	1.5

Other Lens Brightfield objective lense CFI L Plan EPI 40x

A 40x objective lens is best for metal analysis.

NA: 0.65 W.D.: 1.0mm



Digital camera system for microscopes DIGITAL SIGHT SERIES

DS-Ri2 Capable of expressing images as is, DS-Ri2 offers high resolution, color reproduction, and frame rate. The Stand- Alone Model enables high-definition image acquisition without a control unit.Image: Discussion of the stand- Alone Model enables high-definition image acquisition without a control unit.Image: Discussion of the stand- Alone Model enables high-definition image acquisition without a control unit.Image: Discussion of the stand- Alone Model enables high-definition image acquisition without a control unit.Image: Discussion of the stand- Alone Model enables high-definition image acquisition without a control unit.Image: Discussion of the stand- to	Microscope came	OSCOPE camera Stand-Alone Model		Microscope camera	
Max Recordable	Capable of expressing DS-Ri2 offers high res reproduction, and fran Alone Model enables mage acquisition with 16.25	solution, color me rate. The Stand- high-definition nout a control unit.		Features high- resolution, high sensitivity/low noise, and high-speed live display, all in one camera.	
Max Recordable	Frame Rate	45fps (1636×1088)		30fps (1440×1024)	
Pixels 4908×3264 2880×2048	Max Recordable Pixels	4908×3264		2880×2048	

Microscope camera control unit

DS-L4

DS-Fi3 can be connected to the DS-L4 tablet-style control unit, eliminating the need and space requirements of a desktop PC. DS-L4 has a large number of built-ir security for network connectivity.

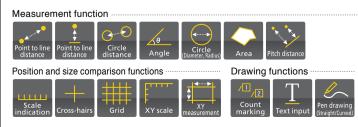
Scene Mode

Optimal imaging parameters for each sample type and observation method can easily be set through the icons.

Variety of Tool Features

Enables easy measurements directly on the images, with input of lines and comments. Measurements can be written and saved with the image, and data can be output.

Measurement (two-point distance)

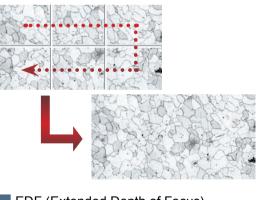


Imaging software NIS-Elements series

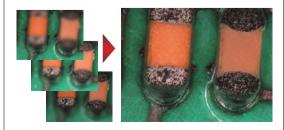


Image Stitching

Stitches together images acquired from multiple fields of view to create one image.



EDF (Extended Depth of Focus) Create a single, all-in-focus image from images of differing focus.



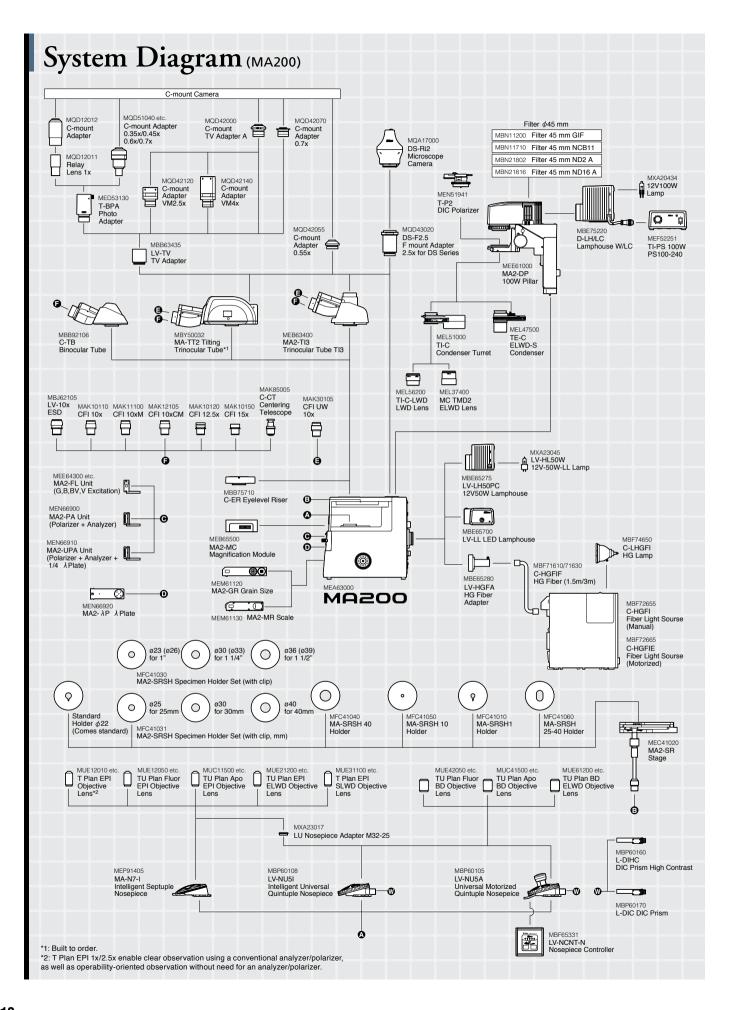
* See the "Digital Camera Digital Sight Series for Microscopes" catalog for details on Digital Sight features.

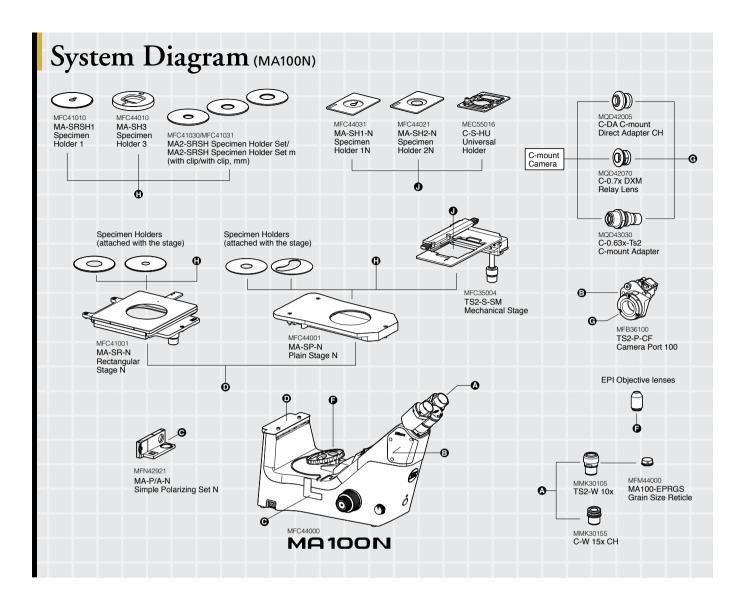
Wafer/IC

Circuit board

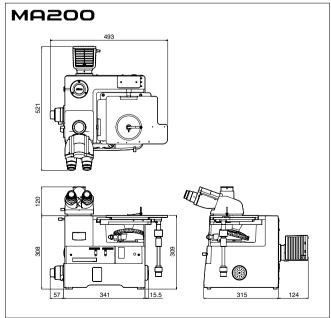
Flat Panel Display

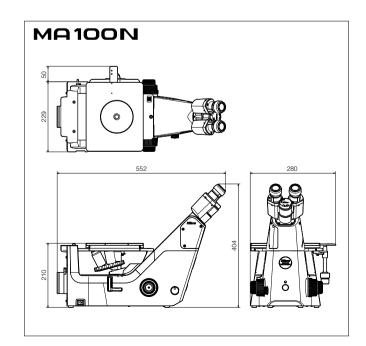
Metal, Ceramic/Plastic





Dimensions





Specifications (MA200)

	МАЗОО			
Main body	Focusing mechanism	Focusing nosepiece (Fixed stage) Coaxial coarse/fine adjustment knob (torque adjustable)		
		Coarse adjustment of 4.0 mm per rotation, fine adjustment of 0.1 mm per rotation		
	Illumination	With flare prevention, Built in UV cut filter		
		Field diaphragm: dialing continuous variable (centerable), Aperture diaphragm: dialing continuous variable (centerable)		
		Filter: Double turret (ND16, ND4/GIF, NCB, Additional option available), Polarizing block (Selectable with or without 1/4 λ Plate)		
		Fluorescence filter blocks: B/G/V/BV		
		12V50W Halogen Lamp, C-HGFI HG Fiber Illuminator, LV-LL LED Lamphouse		
	Light distribution	Eyepiece tube/Back port: 100/0, 55/45		
Optics	CFI60/CFI60-2 system			
Observation image	Surface Image			
Observation method	Bright/Darkfield/Simple Polarizing/DIC/Epi-Fluorescence			
Revolving nosepieces	LV-NU5I: Bright/Darkfield/DIC 5 position nosepiece, LV-NU5A: Motorized Bright/Darkfield/DIC 5 position nosepiece			
	MA-N7-I Brightfield 7 position nosepiece (Intelligent)			
Stage	MA2-SR Mechanical Stage (X/Y flexible handle)			
	Dimension: 295x215mm, Stroke: 50mmx50mm (with distance graduation), Standard accessory: ø22 universal specimen holder (with sample clip)			
Trinocular eyepiece	Siedentopf interpupillary distance adjustment 50-75mm			
Power input	100-240V, 50-60Hz			
Power consumption (max.)	.) 1.2A 75W			
Weight	Approx. 26 kg (depends on combination)			
Options	Intermediate magnification	Initication Turret (1x, 1.5x, 2x), Status detection (Output magnification information to main unit) MA2-GR Grain Reticle (ASTM E112-63 grain sizing numbers 1 to 8), Grid Reticle(20 lines, 0.5mm)		
	Scale			
		MA2-MR Scale Reticle (compatible with 5-100x, Read in um, Dialing System)		

Specifications (MA100N)

	MA 100N				
Optics	CFIeo/CFIeo-2 system				
Observation image	Reversed image				
Observation method	Brightfield and polarization (with MA P/A simple polarizer/analyzer set)				
Focusing	Focusing nosepiece (fixed stage), coaxial coarse/fine adjustment knob with 8.5-mm stroke				
	(Coarse adjustment of 37.7mm per turn, fine adjustment of 0.2 mm per turn)				
Nosepiece	Brightfield 5-position nosepiece				
Stage	MA-SR-N Rectangular 3-plate Stage N: 50×50 mm stroke (includes two stage inserts (ø20 mm and 40 mm opening) and coaxial control handle on the right side_				
	The 3-plate design allows entire top surface to move. Optional Stage inserts: MA-SRSH1 Specimen Holder 1 with (ø15mm opening or MA-SH3				
	Specimen Holder 3 with 2 mm to 32 mm adjustable opening				
	MA-SP-N Plain Stage N: 188x310 mm - Includes two stage inserts (1) clear acrylic stage insert with ø30mm opening, (2) clear acrylic stage insert				
	with crescent opening (width 30 mm) to allow clearance for rotation of high magnification objectives				
	Optional stage inserts: MA-SRSH1 Specimen Holder 1 with 15mm opening or MA-SH3 Specimen Holder 3 with 2 mm to 32 mm adjustable opening				
	Accepts Attachable Mechanical Stage TI-SM				
	TS2-S-SM Mechanical Stage: 126 mm×78 mm stroke, handle can be attached on the right or left side of the plain stage				
	Optional Specimen Holders to fit Attachable Mechanical stage: MA-SH1-N Specimen Holder 1N (ø15 mm opening)				
	MA-SH2-N Specimen Holder 2N (ø30 mm opening), or C-S-HU Universal Holder (30 mm to 65 mm adjustable opening)				
Illuminator	Internal power supply white LED light source, condenser built-in (lever operated), ø25 mm filter can be inserted				
Binocular body	Built-in Siedentopf binocular, 45 inclination angle and 50 to 75-mm interpupillary adjustment, attachable camera port, eyepiece/Port: 100/0:0/100				
Power consumption (max.)	15W				
External dimensions	229x552x404 mm (WxDxH)				
Weight	Approx. 10 kg				

Specifications and equipment are subject to change without any notice or obligation on the part of the manufacturer. May 2018 ©2006-2018 NIKON CORPORATION

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TO ENSURE CORRECT USAGE, READ THE CORRESPONDING MANUALS CAREFULLY BEFORE USING THE EQUIPMENT.



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